



Docket No.: SON-1718  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:

Yasukiyasu Sugano et al.

Application No.: 09/478,812

Confirmation No.: 2204

Filed: January 7, 2000

Art Unit: 2815

For: PROCESS FOR PRODUCING THIN FILM  
SEMICONDUCTOR DEVICE AND LASER  
IRRADIATION APPARATUS

Examiner: E. Lee

**AMENDMENT AFTER FINAL ACTION (37 C.F.R. SECTION 1.116)**

MS AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated October 22, 2005, finally rejecting claims 11, 12, 17, 18, 27, 28, 39, 40, 53, 54, 63, 65, 73, and 74, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks/Arguments begin on page 12 of this paper.

*Handwritten notes:*  
In General  
w/ PACE  
11-21-05  
Amended  
11-29-05  
12-9-05